



TJK/204

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Chang Gyu KIM et al.

) METHOD FOR FORMING ISOLATION
LAYER OF SEMICONDUCTOR DEVICE

Korean Application No. 2001-15415

)) Group Art Unit: 2823

Korean Filing Date: March 24, 2001

)) Examiner: N. Berezny

Serial No.: 10/001,314

)

Filed: November 14, 2001

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PETITION AND FEE FOR EXTENSION OF TIME (37 CFR 1.136(a))

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a petition for an extension of time to respond to the Office Action mailed on June 16, 2003.

The extension is for one month for a fee of \$110.00 and a check is enclosed which covers this fee.

Please charge any additional fees, including extension fees, or credit any overpayment to Deposit Account No. 23-2126. An extra copy is enclosed.

10/22/2003 SSESHE1 00000056 10001314

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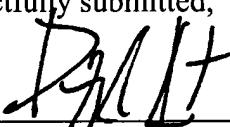
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Date: 10/16/03

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Respectfully submitted,

By: _____


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I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450. Christine A. Smola